

<b>Notice of References Cited</b>	Application/Control No. 10/719,197		Applicant(s)/Patent Under Reexamination GAMMEL ET AL.	
	Examiner Ida M. Soward		Art Unit 2822	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0051120	03-2004	Kato, Toshikazu	257/200
*	B	US-2003/0213971	11-2003	Yu, Ta-Lee	257/119
*	C	US-6,015,992	01-2000	Chatterjee et al.	257/350
*	D	US-2004/0072391	04-2004	Chen et al.	438/134
*	E	US-6,756,270	06-2004	Lee, Chang Soo	438/258
*	F	US-6,888,177	05-2005	Nemati et al.	257/132
*	G	US-2001/0015452	08-2001	Shinkawata, Hiroki	257/306
*	H	US-2005/0078534	04-2005	Tran et al.	365/200
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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